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Application No.	Applicant(s)	
09/740,901	KIDERA ET AL.	
Examiner	Art Unit	
Mary C Hogan	2123	

SEARCHED				
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
toshiba.as. and hidetuki.in. : east, ACM, IEEE	11/16/2004	мсн
EAST: conner model, parameter, process, variation, semiconductor, circuit	11/16/2004	мсн
IEEE: 'corner model' <and>'process parameter'<and>semiconductor ACM: +"corner model" "electrical characteristic" "process para</and></and>	11/16/2004	МСН
Google: "corner model" process condition simulation parameter	11/16/2004	MCH
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